



SW Test Workshop
Semiconductor Wafer Test Workshop

Enabling High Parallelism in Production RF Test



Patrick Rhodes
Ryan Garrison
Ram Lakshmanan
FormFactor

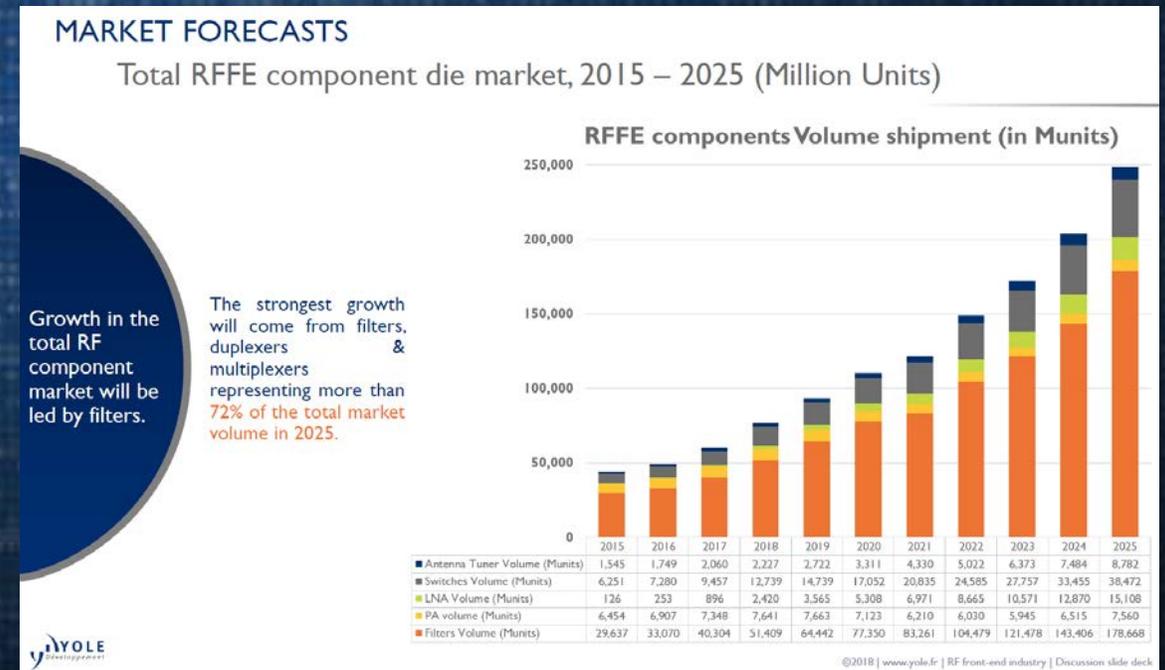
June 3-6, 2018

Connectivity is Driving Change

The connected world is driving the growth of RFICs in the market. These RFICs include – Filters, PAs, Switches for the front end and WiFi, BlueTooth, combo devices at the SoC level

Typically probing needs are:

- ❑ Operating frequency: <10GHz
- ❑ Loss Characteristics: -3dB IL/-10dB RL
- ❑ Ground Inductance: <0.8nH
- ❑ Higher Parallelism: larger volumes to test and increasing ATE capabilities



Example of Test Challenges

- **Combo devices:**

- High RF channel count
- Large general I/O count
- High power requirements
- Long test times
- Delicate solder structures

- **High Speed Digital**

- Large high speed channel count
- Large dies
- Stringent pad damage requirements

...all in a volume mfg. environment



X8 Array with >3000 Contacts and 6 GHz signals
Limited options for probe technology, all with trade-offs

Limitations with Existing Solutions

- Traditionally, device manufacturers have deployed probe cards that support high frequency signals (>3 GHz) OR mechanically robust multi-site probe cards, but not both
- Many of the ingredients needed to get to a mechanically robust, frequency capable, multi-site probe card have been around for years, but gaps remained

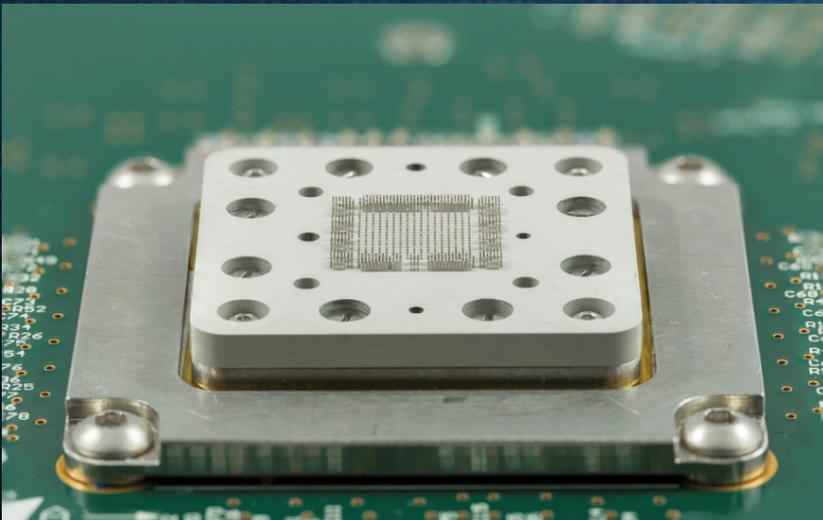
Pogo Pin Limitations

The GOOD:

- Readily available
- Low cost
- High CCC

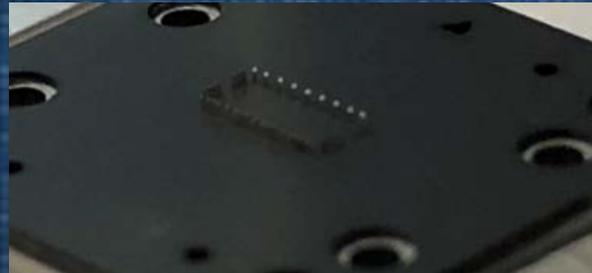
The LACKING:

- Pitch and frequency limited
- High inductance
- Maintenance-intensive
- High force



Getting to Higher Parallelism in RF Test

- We'll explore a new combination of the existing ingredients, as well as a technological sweetener that completes the picture, for a robust, multi-site probe card for production RF test



A New Ingredient!

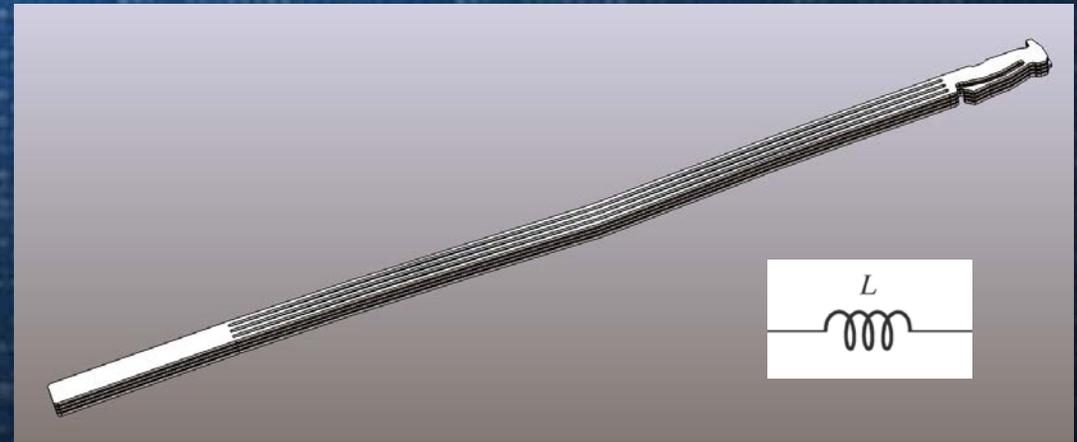
Ingredient 1 – Vertical MEMS

The GOOD:

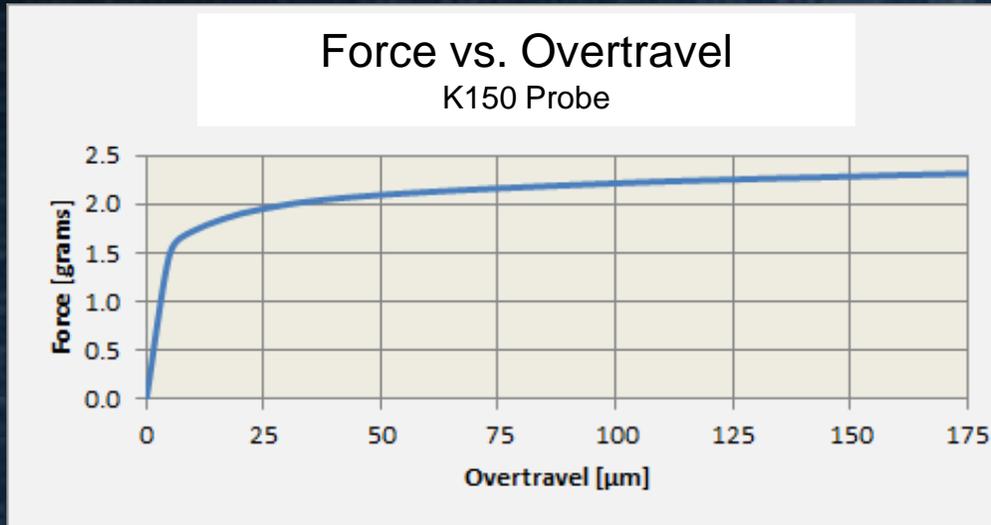
- *Lots of people make these now, but only some are reasonably short*
- **Low Force (~2 grams at maxOT)**
- **Long Lifetime**
 - Mechanically these will exceed 1M touchdowns, considering both fatigue and wear
- **High CCC (~1A, depending on type)**
- **Easily Replaceable**
- **Scalable to large arrays and many sites**

The LACKING:

- Vertical MEMS probes are essentially series inductors in traditional implementations



Ingredient 1 Details



Buckling action of these probes makes good contact quickly, and leaves plenty of usable overtravel

Probe Type	K400 (7-leaf)	K150 (4-leaf)	K80* (3-leaf)
Probe Technology	Vertical MEMS	Vertical MEMS	Vertical MEMS
Available Probe Tip Shape	Flat	Flat, Pointed	Flat, Pointed
Minimum Pitch [μm]	130 Inline Single Row (→105)	112 Inline Single Row (→87)	112 Inline Single Row (→87)
	200 Square Grid	150 Square Grid	130 Square Grid
	300 anywhere	175 anywhere	150 anywhere
Flat Tip Size (um)	80 x 200	51 x 76	51 x 55
Pointed Tip Size (um)	-	16 x 16	16 x 16
Probe Force at Production OT(g)	5~6	2.1~2.3	1.9~2.1
Max OT [um]	350	175	125
CCC [A]	1.5	1.1	0.8
Probe Length [mm]	2.95/3.75	2.79	2.79
Operating Temperature	-40~160C	-40~160C	-40~140C
Loop Inductance	0.6-1.2 nH GSG	0.4 nH GSG	0.4 nH GSG
@ Assembly Minimum Pitch	1.0-1.8 nH GS	0.75 nH GS	0.75 nH GS
Repairability	Single Probe Replaceable		

Ingredient 2 – Membrane Space Transformer

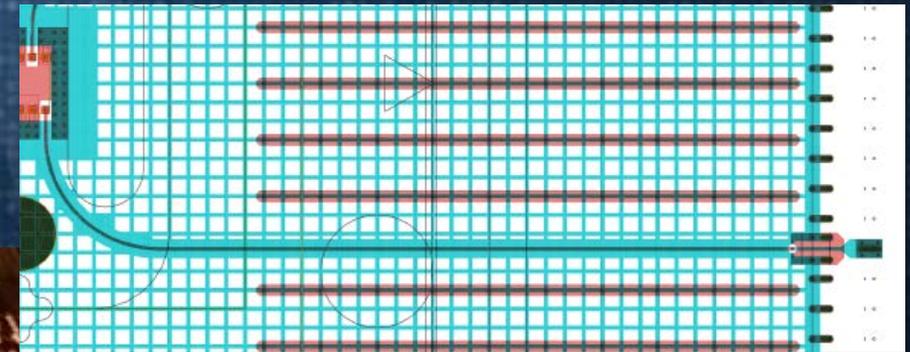
(now with only 1 job – space transformation)

The GOOD:

- *These have been around for a long, long time*
- **Straightforward transmission line routing from one end to the other**
- **Short lead times**
- **More cost effective than typical MLO space transformers**

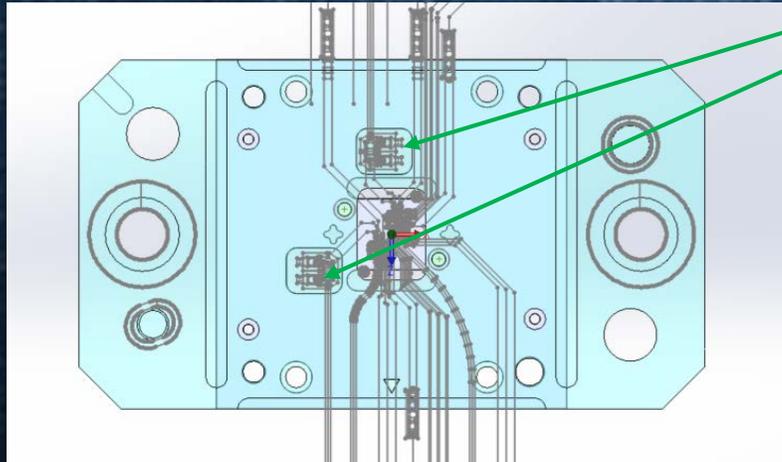
The LACKING:

- **Traditional use of these as a space transformer AND a contactor has limitations**
 - Large arrays can be mechanically unwieldy
 - Repairs often not possible



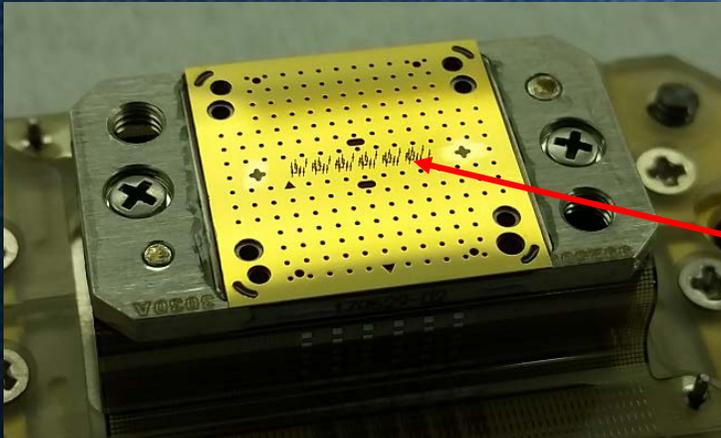
Benefits of Ingredient 2

- Use of the membrane as a space transformer only is far simpler than using it as a space transformer AND contactor
- It frees the membrane up for some *fringe benefits*
 1. Additional space in general – landing pads for vertical probe distal ends take up less space
 2. Loopbacks – see also: extra space
 3. Component placement – right on the membrane face, underneath the spring head and very close to the die



Ingredient 3 – The New One!

So now we have vertical MEMS probes and a membrane space transformer. This is great for DC applications, *but that's not the endgame*. The combination is part way there, but now we're dangling an inductor off the end of a nice transmission line.



Bringing Balance to the Force:

- Add a metal layer to the guide plates
- Connect these metal layers to GND
- Connect all the GND probes to this metal layer
- Isolate all other probes from this metal layer

All GND probes are always in contact with the metal guide plate, all non-GND probes are isolated from the metal guide plate

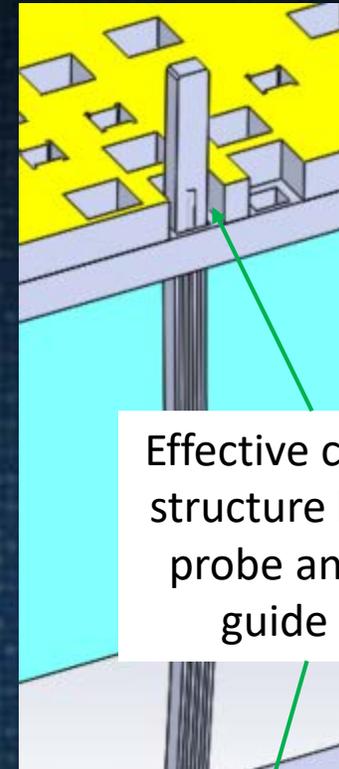
Benefits of Ingredient 3

So now we have metal+ceramic guide plates:

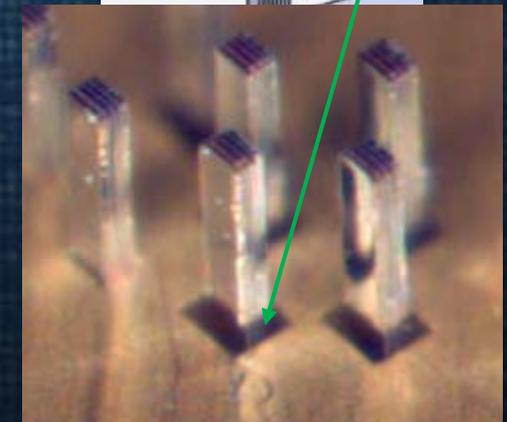
- Enjoy the capacitance that the metal layer adds...and the balancing effect to the typically inductive vertical MEMS probe
- Further enjoy the ground plane between the die and space transformer
- Continue to enjoy the robust mechanical characteristics of ceramic guide plates (long lifetime, accurately feature placement, etc)

→ *Loss characteristics are improved over typical vertical MEMS probe cards*

→ *The die and space transformer are nicely shielded from one another*

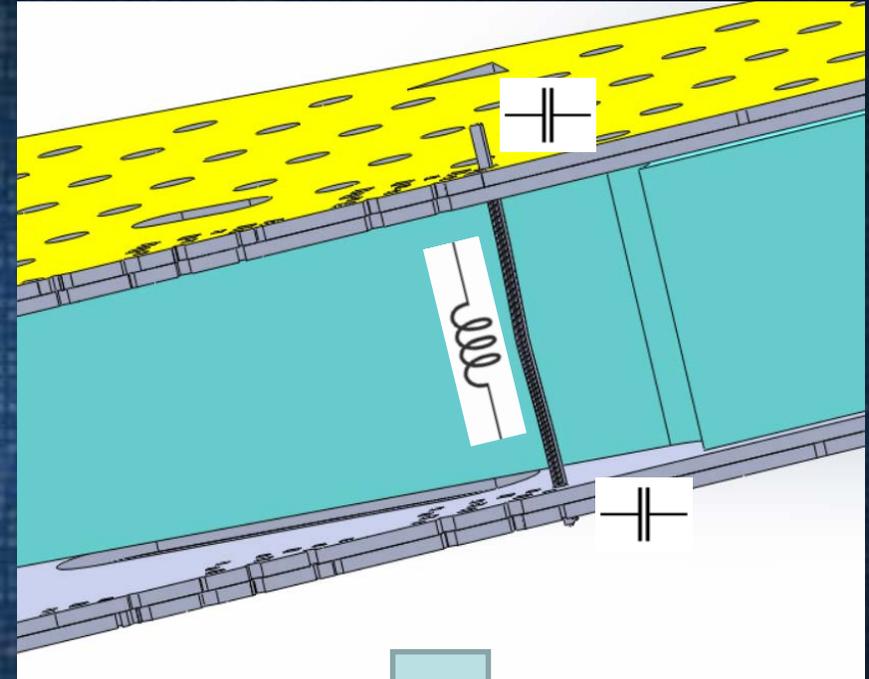


Effective capacitive structure between probe and metal guide plate



Putting it Together (Pyramid + Katana = Pyrana)

- Frequency performance – to about 10 GHz considering insertion and return loss
 - Dependent on die layout and other factors
- Isolation – die and space transformer aren't talking to one another
- [Standard benefits of vertical MEMS]
- [All the pluses of a thin-film space transformer]



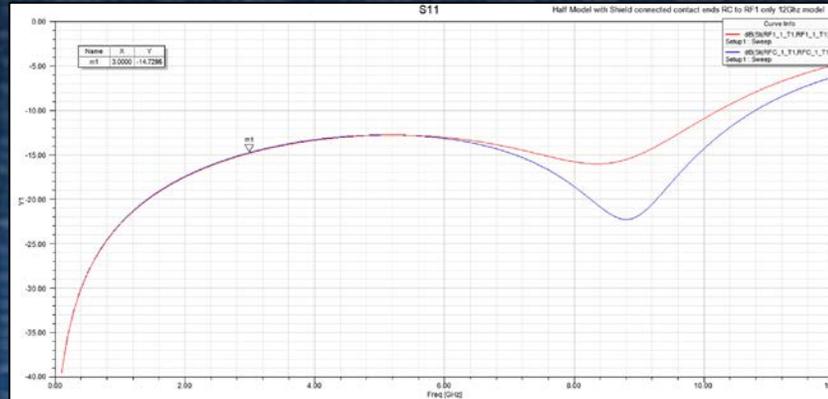
It's imperfect, but it moves the probe head back towards a 50 ohm environment; the space transformer is already there

How We Got Here: Simulations

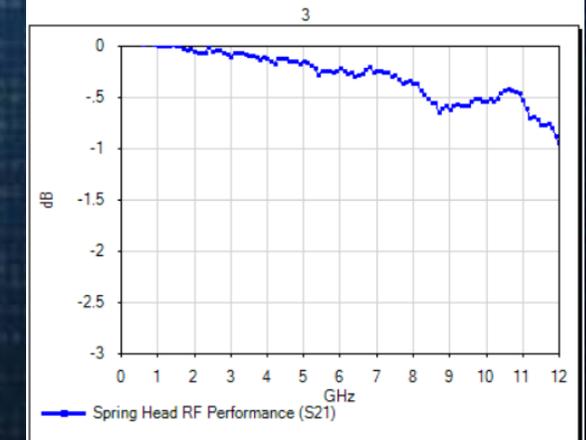
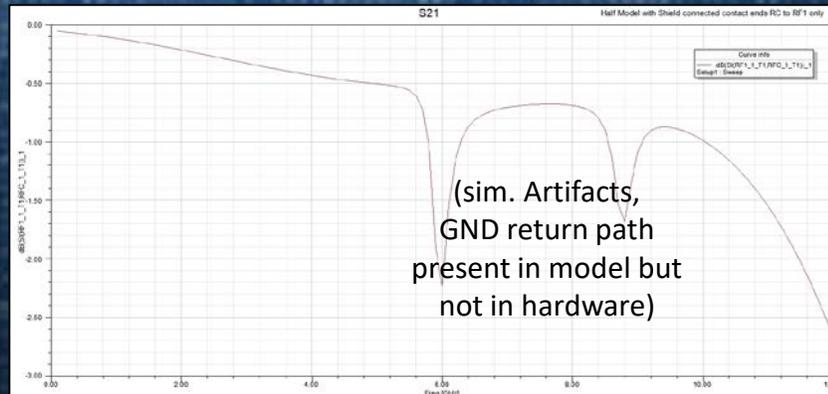
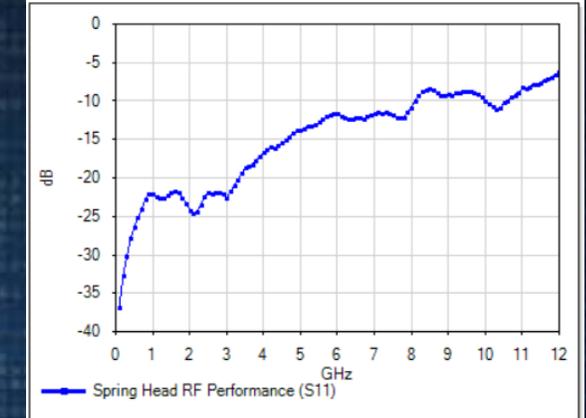
(spring head only)

- The spring head remains the least ideal portion of the signal path
- Simulations for RL/IL suggest loss contributions, and measurements largely agree

Simulated

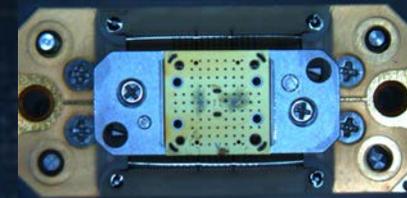


Measured/De-embedded

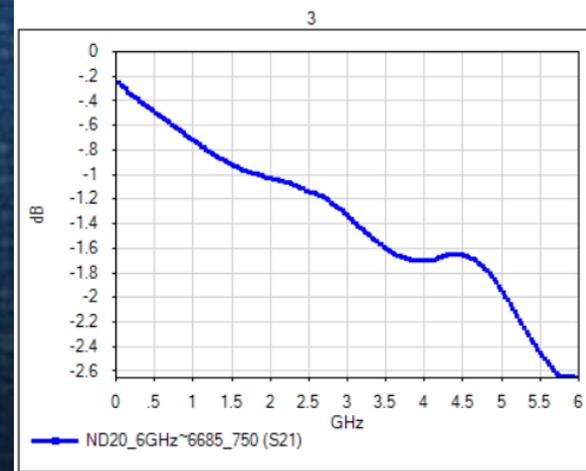
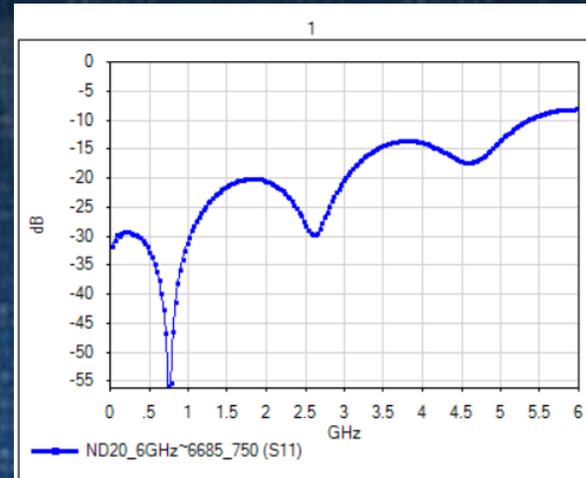


Case 1: Testing a Filter

- **Need:** mechanically robust probe technology with low loss (able to see defined passband), DC to 6 GHz
- Entire signal path shown in S-parameters at center (connector to probe tip)
- Defined passband as seen through the probe card at right

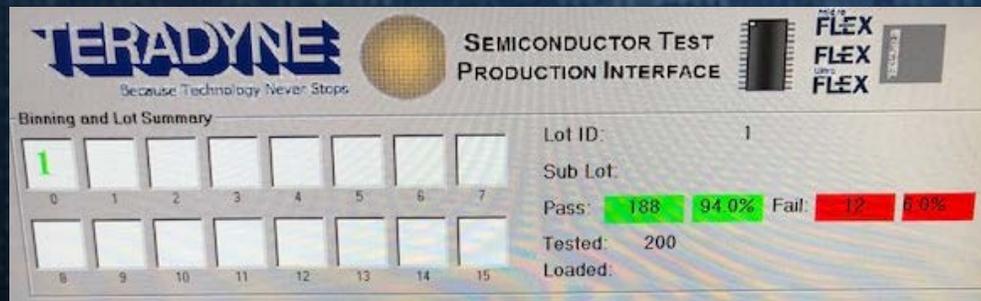


PV6: Smallest Pyrana Probe Head



Case 2: Testing a Large Die, Lots of RF lines

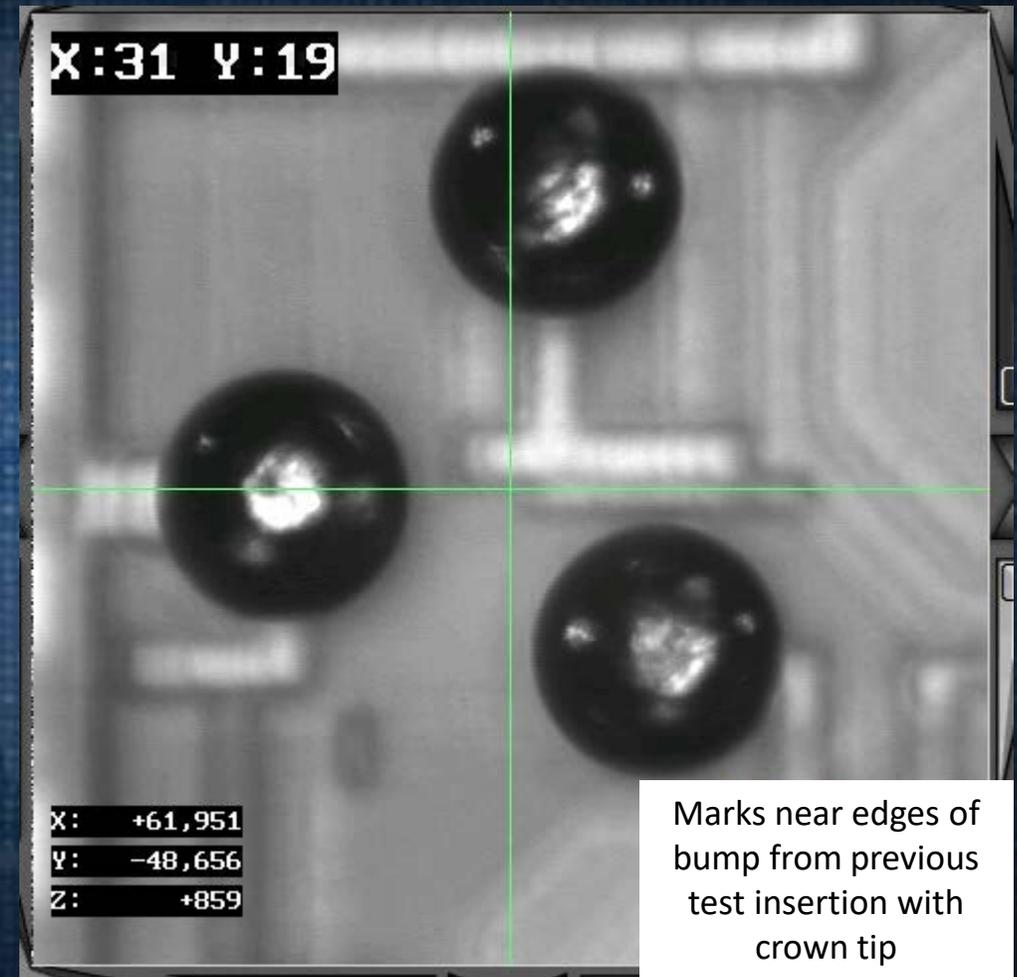
- A device with 32 RF lines for multiple radios shows yield loss due to insertion/return loss and crosstalk with more traditional probe technology
- Using a vertical head with a metal guide plate maintains yield >90% over the course of a full wafer
 - Uncalibrated, but with repeatable results
 - RF power levels as seen by tester better than expected
- Isolation and attenuation issues attributable to the contacts are largely addressed
- Heads used in a non-cleanroom engineering environment suffered damage due to overcurrent events, handling, etc, but repairs were generally straightforward



Test Data, about as sanitized as it gets!

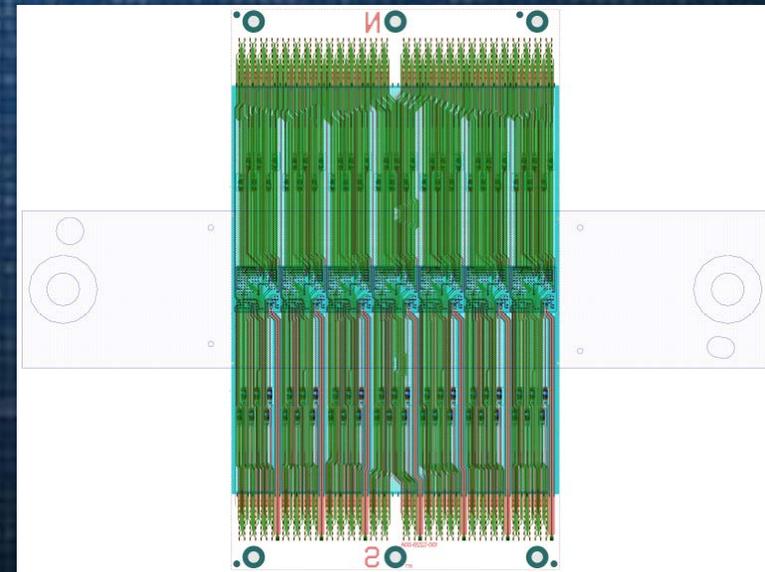
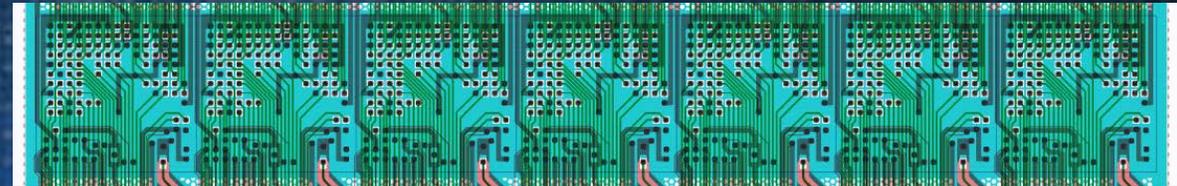
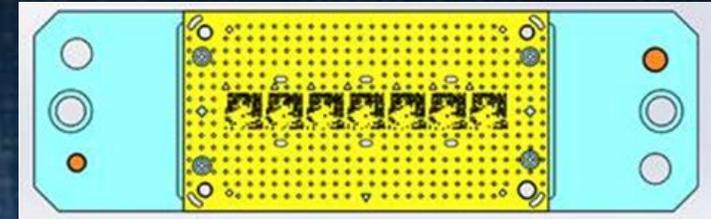
Case 2: Probe Marks

- Low force and modest but non-zero scrub minimizes bump damage while maintaining good contacts
- Bumps at right are 90 μm tall, 120 μm diameter
- Top $\sim 1/3$ of hemisphere is *coined* but otherwise undisturbed

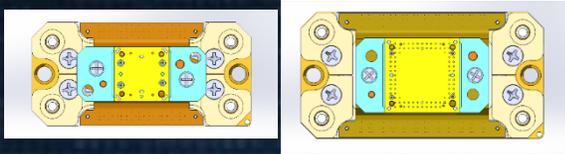


Case 3: Scaling Up

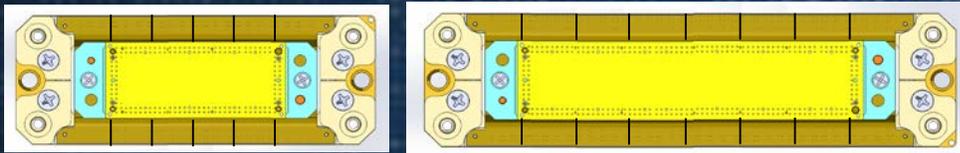
- 7-site testing of a Bluetooth device on a Teradyne UltraFlex tester
- Array size approximately 24 mm in the long dimension
- *Need: probe technology that takes advantage of 7-site tester capability, without mechanical shortcomings*
- *This design is complete, parts are in manufacturing, and will be evaluated over the second half of 2018*
- *Additional multi-site designs now in process*



Pyrana – Additional Details



PV6	PV10
6mm x 6mm	10mm x 10mm



PV35	PV75
35mm x 10mm	75mm x 12mm

- 4 standard sizes for probe heads, with active areas shown
- Coverage for a wide range of devices, site counts, pin counts
 - Filters to RF-SoCs
 - Inductance-sensitive devices, including MEMS sensors and power amplifiers
 - Tens of sites
 - Tens to thousands of probes
 - *Pin count is typically not the limiting factor*
- Standard probe head footprints make generic, low-cost PCBs a real possibility

Additional Product Data: www.formfactor.com/product/probe-cards/rf-mmw-radar/pyrana/

Pyrana Future

- **New vertical probe card architecture is opening new doors right now, but there's more to come:**
 - Drive to higher frequencies to support expanded applications
 - Improved pitch capability
 - Lead time reduction
- **Actively pursuing improvements to the Pyrana architecture to address all of these**

Wrap Up

- **Pyrana is an effective combination of a couple of existing, proven technologies plus a new ingredient**
- **It offers the possibility of much higher parallelism for all kinds of devices with signals up to 10 GHz**
 - Today's 10 GHz limit represents a trade – a lower frequency limit for a number of mechanical advantages
 - This limit is a soft one, as we're already driving toward improved bandwidth capability

Thank You!

- **Patrick Rhodes – Product Engineer,**
Patrick.Rhodes@formfactor.com
- **Ram Lakshmanan – Marketing Manager,**
Ram.Lakshmanan@formfactor.com
- **Please question away!**